



PATENT APPLICATION

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on Nov 17, 2003.

11/17/03
Date

Delbert J. Barnard
Delbert J. Barnard
Registration No. 20,515

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2878
Examiner: Shun K. Lee
Applicant: Ger van den Engh
Serial No.: 09/847,466
Filed: May 1, 2001
For: APPARATUS FOR DETERMINING RADIATION
BEAM ALIGNMENT
Date: November 17, 2003

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TECHNOLOGY CENTER 2800

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the due date for filing a Response to the Office Action dated September 16, 2003, be extended from October 16, 2003 to November 17, 2003 (November 15, 2003 and November 16, 2003 being a Saturday and Sunday).

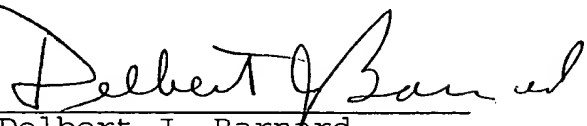
A check for the extension fee of \$55.00 as set forth in 37

C.F.R. 1.17(a) is enclosed. Please charge any additional extension fees to Deposit Account No. 02-0915. Two duplicate copies of this Petition are enclosed.

Respectfully submitted,

GER VAN DEN ENGH

By:

A handwritten signature in cursive script, appearing to read "Delbert J. Barnard", written over a horizontal line.

Delbert J. Barnard
Attorney for Applicant
Registration No. 20,515
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DJB/lam